

APPLICATION DATA SHEET

Application Information

Application Type:: Regular
Subject Matter:: Utility
Title:: METHOD FOR THE PRODUCTION OF
LOW DEFECT DENSITY SILICON
Attorney Docket Number:: 985401/23401
Total Drawing Sheets:: 3
Small Entity?:: No

Applicant Information

Applicant Authority Type:: Inventor
Primary Citizenship Country:: Russia
Status:: Full Capacity
Given Name:: Vladimir
Middle Name:: V.
Family Name:: Voronkov
City of Residence:: Merano
Country of Residence:: Italy
Street of Mailing Address:: Via Nazionale, 59
City of Mailing Address:: Merano
State or Province of Mailing
Address:: Italy
Postal Code of Mailing Address:: 39012

Applicant Authority Type:: Inventor
Primary Citizenship Country:: US
Status:: Full Capacity
Given Name:: Robert
Middle Name:: J.

Family Name:: Falster
City of Residence:: London
Country of Residence:: England
Street of Mailing Address:: 501 Pearl Drive, P.O. Box 8
City of Mailing Address:: St. Peters
State or Province of Mailing
Address:: MO
Postal Code of Mailing Address:: 63376

Applicant Authority Type:: Inventor
Primary Citizenship Country:: Iran
Status:: Full Capacity
Given Name:: Mohsen
Family Name:: Banan
City of Residence:: Grover
State or Province of Residence:: MO
Country of Residence:: US
Street of Mailing Address:: 501 Pearl Drive, P.O. Box 8
City of Mailing Address:: St. Peters
State or Province of Mailing
Address:: MO
Postal Code of Mailing Address:: 63376

Correspondence Information

Correspondence Customer Number:: 000321

Representative Information

Representative Customer Number:: 000321

Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This application	Non-Provisional of	60/275,715	11/22/00
This application	Non-Provisional of	60/245,610	11/3/00

Assignee Information

Assignee Name::

MEMC Electronic Materials, Inc.